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Controlled preparation of Ag nanoparticles on graphene with different amount of defects for surface-enhanced Raman scattering

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Graphene with different amounts of defects was prepared by chemical vapor deposition by controlling the flow rate of hydrogen, on which Ag nanoparticles (NPs) were deposited by magnetron sputtering. It is certified that the defects mainly consist of C–O bonds that affect the morphology and distribution of the prepared Ag NPs. The Ag NPs/graphene composition exhibits good surface-enhanced Raman scattering activity, which is largely increased by increasing the percentage of the functional group C–O in graphene.

1. Introduction

Surface-enhanced Raman scattering (SERS) has been used as a powerful tool for the detection of the structures of molecules in many fields such as materials, biosensing, chemistry, and physics.^{1–6} It has attracted significant attention since SERS was first discovered on a rough Ag surface by Fleischmann in 1974.⁷ As is well-known, SERS results from a combination of electromagnetic enhancement mechanisms (EM) and chemical enhancement mechanisms (CM).^{8–10} The EM originates from the surface plasmon resonance, which is originated from metal NPs, and the CM is caused by charge transfer between the probe materials and the substrates.^{11,12} To date, noble metals, such as Au, Ag, and Pt, have been widely utilized for SERS.¹³ Han *et al.* found that Ag showed a better SERS activity as compared to other metals.¹⁴ Malynych *et al.* indicated that Ag NPs more efficiently interacted with light than any other particles with the same dimensions.¹⁵ Moreover, Kha *et al.* have reported that Ag is the only material whose plasmon resonance can be tuned to any wavelength in the visible spectrum.¹⁶ However, Ag NPs are easily oxidized in air, and they have a high fluorescent background and low adsorption of the probe molecules, which will limit their SERS activity.¹⁷ Therefore, finding an ideal substrate for SERS becomes most desirable.

Graphene, a two-dimensional lattice of carbon with only one atom layer, has been a hot research topic because of its excellent optical, electronic, and mechanical properties.^{18–20} Especially, graphene enables charge transfer with probe materials through the π – π bonds. Recently, metals and graphene hybrids were used as SERS substrates, where graphene could absorb probe molecules, protect metals from oxidation, and quench

fluorescence from the metals.^{21–23} For example, Zhang *et al.* covered metal NPs with graphene, which served as a barrier to preserve the metal NPs and effectively suppressed the photobleaching effect.²⁴ Li *et al.* designed a system by introducing graphene as a subnanospacer between Ag NPs and the Ag film, which showed a high SERS intensity since graphene strengthened the ability to efficiently interact with probe molecules and quench the fluorescence background.²⁵

Developing a graphene–Ag NPs hybrid that combines the properties of CM enhancement and EM enhancement is applicable for SERS. Recently, it has been widely studied that how the structures of this hybrid affect the SERS activity. For instance, Leem *et al.* introduced a three-dimensional graphene–metal hybrid that exhibited higher detection sensitivity of the probe material as compared to the uniform graphene–metal substrates.²⁶ Fu *et al.* developed a system with Ag NPs by sputtering and photochemical catalysis to prove that different densities of Ag NPs can create different Raman intensities.²⁷ Wang *et al.* enlarged the surface area and modified the morphologies of the metals to obtain stronger SERS intensity.²⁸ In these researches, significant attention was paid to change the structures of the metal materials and graphene hybrids. In fact, graphene itself when used as an SERS platform possesses different defects and layers,^{29,30} which can affect the SERS activity. However, few researchers have reported that the defects in graphene affect the SERS activity of the hybrids.

In this study, graphene with different percentages for C–O was grown on a Cu foil by chemical vapor deposition (CVD), and different amounts of C–O were produced on it by controlling the flow rate of hydrogen during the reaction. Ag NPs were sputtered on graphene for SERS; the different amounts of C–O on graphene can lead to the divergence of Ag distribution. The relationship between the C–O in graphene and SERS activity was investigated. Statistical results indicated that the prepared

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graphene and Ag NPs obviously exhibited diverse Raman enhancement for rhodamine 6G molecules.

2. Experimental

2.1. Preparation of graphene

Graphene sheets were grown on copper foils (25 μm thickness and 99.8% purity, Alfa Aesar) by CVD.³¹ In a typical process, Cu foils were cleaned by ultrasonication in an acetone solution, ethanol, and deionized water for 15 min, successively. After cleaning, Cu foils were placed into a quartz tube before the quartz tube was vacuumed (10^{-1} Pa) to remove oxygen. Then, the tube was filled with a mixed gas of H_2 and Ar with the flow rates of 100 and 700 sccm, respectively. After this, the temperature of the quartz tube was increased from room temperature to 1050 $^\circ\text{C}$. Before the reaction, the temperature in the tube was decreased to 1000 $^\circ\text{C}$ and the flow rates of H_2 and Ar were changed to X (X ranges from 10 to 500 sccm) and 1000 sccm, respectively. Then, methane (CH_4) with a flow rate of 9 sccm was introduced to the quartz tube as a carbon source for 15 min. Graphene with different amounts of defects was synthesized by adjusting the flow rate of X for H_2 . At last, the samples were cooled down to room temperature under the protection of Ar and H_2 with the flow rates of 1000 and 10 sccm, respectively. The samples were labeled as shown in Table 1.

2.2. Deposition of the Ag NPs

Graphene was transferred from Cu foils to Si substrate by the traditional method where samples were soaked in a FeCl_3 solution to etch the Cu foils and washed with deionized water.³² Ag NPs were sputtered on the prepared graphene with different amount of defects by a vacuum magnetron sputtering system (JCP-200, BTSC563). The working pressure was 1 Pa under an Ar environment, and the sputtering power was 20 W. The sizes of the Ag NPs were optimized by altering the sputtering time from 15 to 20 s.

2.3. SERS measurements

R6G with different concentrations (from 10^{-5} to 10^{-7} M) was selected as a probe molecule. In this experiment, 80 μl of R6G

was dripped on each substrate ($1 \times 1 \text{ cm}^2$). Raman spectra were obtained under the same conditions as follows: the exciting light source was a 532 nm He-Ne laser with an excitation power of 0.75 mW, and the laser beam was focused by a 50 \times objective lens.

2.4. Characterization

The sizes and distributions of the Ag NPs on graphene were observed by a scanning electron microscope (SEM; FEI, NOVA NanoSEM 450). The prepared graphene was characterized by X-ray photoelectron spectroscopy (XPS, ESCALAB 250xi) and Raman spectroscopy (Renishaw in Via plus, 532 nm).

3. Results and discussion

3.1. The characteristic of graphene with different flow rates of hydrogen

Raman spectra for graphene prepared at different flow rates of hydrogen ranging from 10 to 500 sccm are shown as Fig. 1a. The characteristic Raman bands of graphene at $\sim 1345 \text{ cm}^{-1}$ (D band), $\sim 1585 \text{ cm}^{-1}$ (G band), and $\sim 2685 \text{ cm}^{-1}$ (2D band) can be clearly observed. However, each sample shows a different intensity of D band, G band, and 2D band, which are affected by the layers and defects of graphene. Amongst these spectra, the spectrum of sample G_{10} exhibits a higher 2D band and a smaller D band, and it was concluded that the sample G_{10} was thinnest as compared to other samples. Moreover, the intensity of the 2D band for the grown graphene decreased with the increasing flow rate of hydrogen. As is known, the D to G band intensity ratio ($I_{\text{D}}/I_{\text{G}}$) is related to the quantity of defects on graphene.³³ Fig. 1b shows that the $I_{\text{D}}/I_{\text{G}}$ ratio for these graphene samples increases with the increasing flow rate of hydrogen. The ratio of $I_{\text{D}}/I_{\text{G}}$ reached its largest value when the flow rate of hydrogen was increased to 100 sccm, indicating that the sample G_{100} had more defects as compared to other samples. Fig. 1c shows the ratio of the G band to 2D band intensity ($I_{\text{G}}/I_{2\text{D}}$), which is related to the numbers of graphene layers.³⁴ The $I_{\text{G}}/I_{2\text{D}}$ ratio increased with the increasing flow rate of hydrogen, illustrating an increase in graphene layers. The $I_{\text{G}}/I_{2\text{D}}$ for sample G_{10} , G_{50} , G_{75} , G_{100} , and G_{200} are 0.561, 0.559, 0.638, 0.715, and 0.915, respectively. It was estimated that the thicknesses for samples G_{10} , G_{50} , G_{75} , and G_{100} are no more than 10 layers and the thickness for sample G_{200} is almost 20 layers. The $I_{\text{G}}/I_{2\text{D}}$ ratios for the rest of the samples kept increasing with the increase of H_2 flow rate. Moreover, the intensities of G band for the samples G_{200} , G_{300} , G_{400} and G_{500} are similar to those of the multilayer graphene. The layers of graphene continue to grow in the presence of more hydrogen. Therefore, graphene exhibits a few layers and contains abundant defects while using hydrogen less than 100 sccm during the CVD growth. In this process, defects would be generated on graphene films, such as edges, grain boundaries, functional groups or structural disorders.³⁵ The core density for growing graphene increased, and the grain sizes of graphene decreased³⁶ with the increasing hydrogen flux from 10 to 100 sccm. Therefore, more grain boundaries and functional groups would be generated on the graphene film at a flow

Table 1 Sample name and the corresponding gas mixtures in the graphene growth stage

Sample name	Flow rates of gases Ar : H_2 : CH_4 (sccm)
G_{10}	1000 : 10 : 9
G_{50}	1000 : 50 : 9
G_{75}	1000 : 75 : 9
G_{100}	1000 : 100 : 9
G_{150}	1000 : 150 : 9
G_{200}	1000 : 200 : 9
G_{250}	1000 : 250 : 9
G_{300}	1000 : 300 : 9
G_{400}	1000 : 400 : 9
G_{500}	1000 : 500 : 9



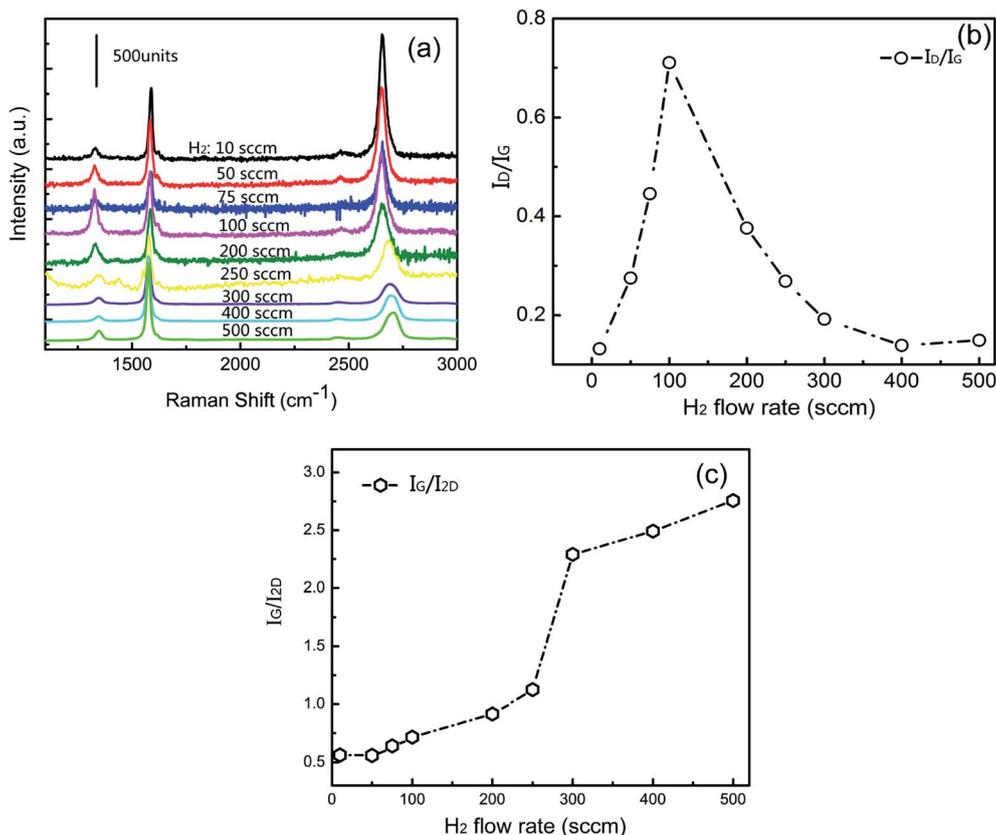


Fig. 1 (a) Raman spectra of graphene grown at different flow rates of H₂. (b) I_D/I_G ratio and (c) I_G/I_{2D} of graphene grown at different flow rates of H₂.

rate of 100 sccm. However, when the hydrogen flux exceeds 100 sccm, the carbon source would be easily diffused and hydrogen would promote the fast removal of residual oxygen or contaminants from the surface. Furthermore, graphene grain sizes would saturate and the number of defects would decrease, such as oxygen-containing functional groups.^{37,38} Graphene enables charge transfer mainly owing to the functional groups, such as phenolic, carboxyl and epoxide groups, on the surface.³⁹ Furthermore, these functional groups on graphene would provide active sites, which can absorb the Ag atoms or clusters to grow into bigger NPs.⁴⁰ Considering this, XPS measurement was performed to determine the functional groups in these graphene films.

Fig. 2a–c show the C 1s XPS spectra for the samples G₁₀, G₁₀₀, and G₂₀₀ on copper. These three C 1s XPS spectra are similar, and the C 1s of graphene is fitted by four peaks, which include four kinds of carbon-containing functional groups: C=C, C–C, C–H, and C–O. C=C bonds and C–C bonds come from the structure of graphene, and C–H bonds in graphene surface comes from the hydrogen etching process. In an argon protected environment, oxygen may have originated from oxides, such as CuO and Cu₂O, at the copper surface. During the reaction, these oxides are reduced into oxygen by hydrogen. Simultaneously, graphene is etched by the released oxygen, and then, the C–O bonds are generated in graphene in this process. It was observed that the percentage of C–H bonds was much less

than that of C–O bonds in each sample, indicating that C–H would not obviously affect the distribution of the deposited Ag NPs. Fig. 2d shows that the percentage for C–O bonds increased when the flow rate of hydrogen was increased from 10 to 100 sccm and then decreased when more hydrogen was introduced. Graphene grain sizes and grain boundaries would saturate when the flow rate of hydrogen is increased to 100 sccm. Functional groups, such as C–O bonds, are mainly generated at grain boundaries.³⁶ Thus, the amount of C–O bonds would change at the air–graphene grain boundaries, which are limited by the flow rate of hydrogen. It is known that C–O is electronegative and it tends to absorb the electropositive Ag atoms or clusters. This suggests that the electronegative C–O in graphene would promote the formation of Ag NPs and affect the distribution and morphology of the Ag NPs. Thus, it is necessary to investigate the relationship between the percentage of C–O and the formation of Ag NPs.

3.2. The distribution and morphology for the Ag NPs on graphene

As shown in Fig. 3a–g (the SEM images), Ag NPs were sputtered on graphene substrates with the same sputtering time. It was observed that the sizes and distances amongst Ag NPs are relatively uniform, but different in each sample. The sizes of Ag NPs become larger when the flow rate of hydrogen is increased



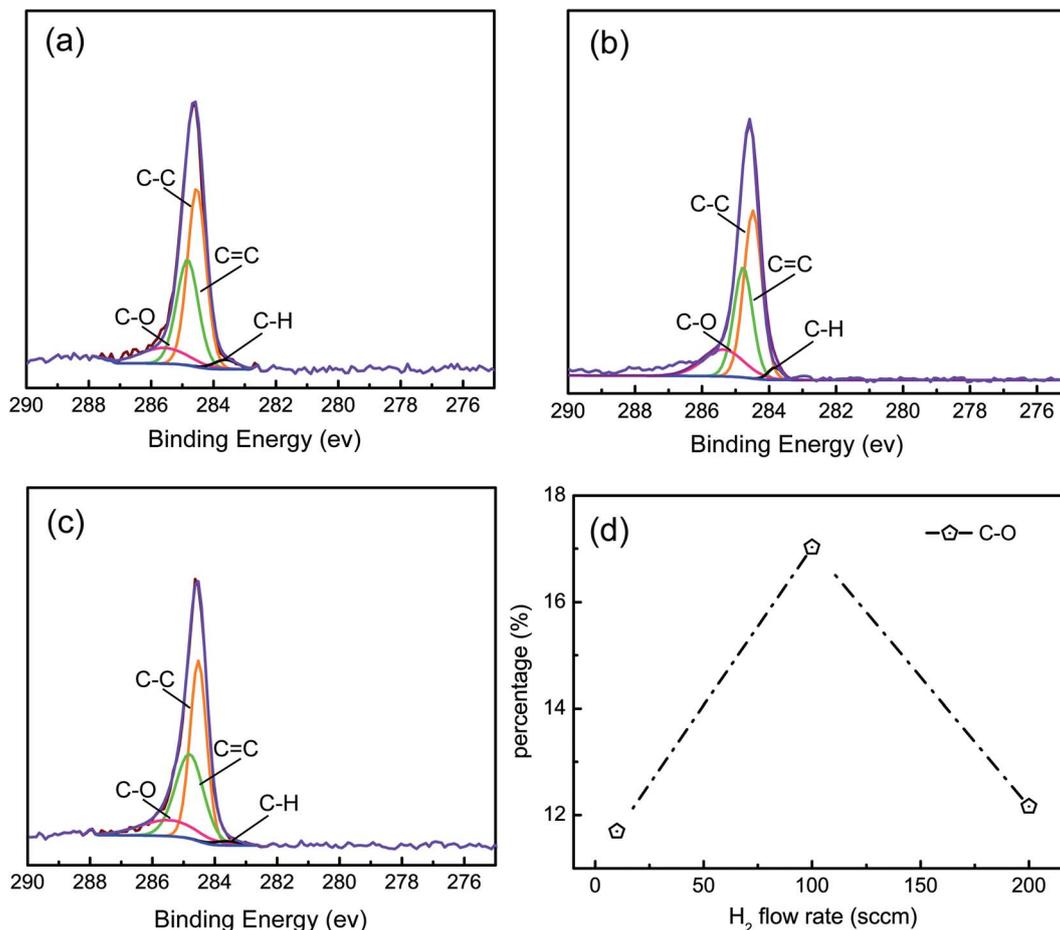


Fig. 2 C 1s XPS spectra for samples of (a) G₁₀, (b) G₁₀₀, and (c) G₂₀₀. (d) The percentage of C–O bonds for graphene.

from 10 to 100 sccm. The sizes of Ag NPs for the G₁₀₀-Ag are larger than those of the rest of the samples, and these become more larger when the hydrogen flux exceeds 150 sccm. The heights of Ag NPs on G₁₀₀ were detected by AFM, which ranged from 2 to 10 nm. However, the distances between adjacent Ag NPs become smaller with the flow rate of hydrogen, which ranges from 10 to 100 nm, and these become larger when the hydrogen flux exceeds 100 sccm. It was indicated that the average sizes for Ag NPs in the sample G₁₀₀ were largest, but the distances were smallest. It is well known that the distance of less than 10 nm between adjacent particles is beneficial for forming hot spots for SERS. Fig. 3h shows the percentage of distances of less than 10 nm between Ag NPs calculated from the corresponding SEM images for the samples G₁₀-Ag, G₅₀-Ag, G₁₀₀-Ag, G₁₅₀-Ag, G₂₀₀-Ag, G₂₅₀-Ag, and G₃₀₀-Ag. Every SEM image was averagely divided to 250 cells by the 50 × 50 grid. Inter-particle distance is defined as the smallest distance between the two particles in a cell. It increases with the flow rate of hydrogen ranging from 10 to 100 sccm and decreases with further increase in the flow rate of hydrogen. The percentage of G₁₀₀-Ag reaches a maximum value because it contains much more electronegative C–O bonds to absorb Ag atoms or clusters to generate higher growth core density. These growth cores grow up and coalesce with each other to form irregular island shapes,

which would contribute to narrowing the distances between Ag NPs to form hot spots, pointed out by the arrows in Fig. 3c. The percentage of C–O bonds sharply decreases when the flow rate of hydrogen exceeds 100 sccm. Most Ag atoms or clusters independently grow into big NPs because of the less active sites density, which is affected by the C–O bonds. It was considered that the maximum amount of hot spots would be generated on the sample G₁₀₀-Ag, which would give the strongest SERS single.

3.3. Raman spectra for G₁₀₀ and G₁₀₀-Ag

Fig. 4 shows the Raman spectra of G₁₀₀ and G₁₀₀-Ag (formed by the deposition of Ag on G₁₀₀ for 90 s). It is shown that the sample G₁₀₀ owns three graphene characteristic Raman bands: D, G, and 2D bands. By contrast, the sample G₁₀₀-Ag owns not only the enhanced three Raman bands, but also the D' band and another D + D' band. According to the research reported by Kalbac *et al.*,⁴¹ the Raman signal of graphene is enhanced by energy transfer from surface plasmon resonance excited between Ag NPs. In addition, the doping of Ag NPs would induce the artificial defects in graphene, which result in the emergence of the D' band and the enhancement of the D band.⁴² The D + D' band is due to two-phonon defect-assisted process.⁴³



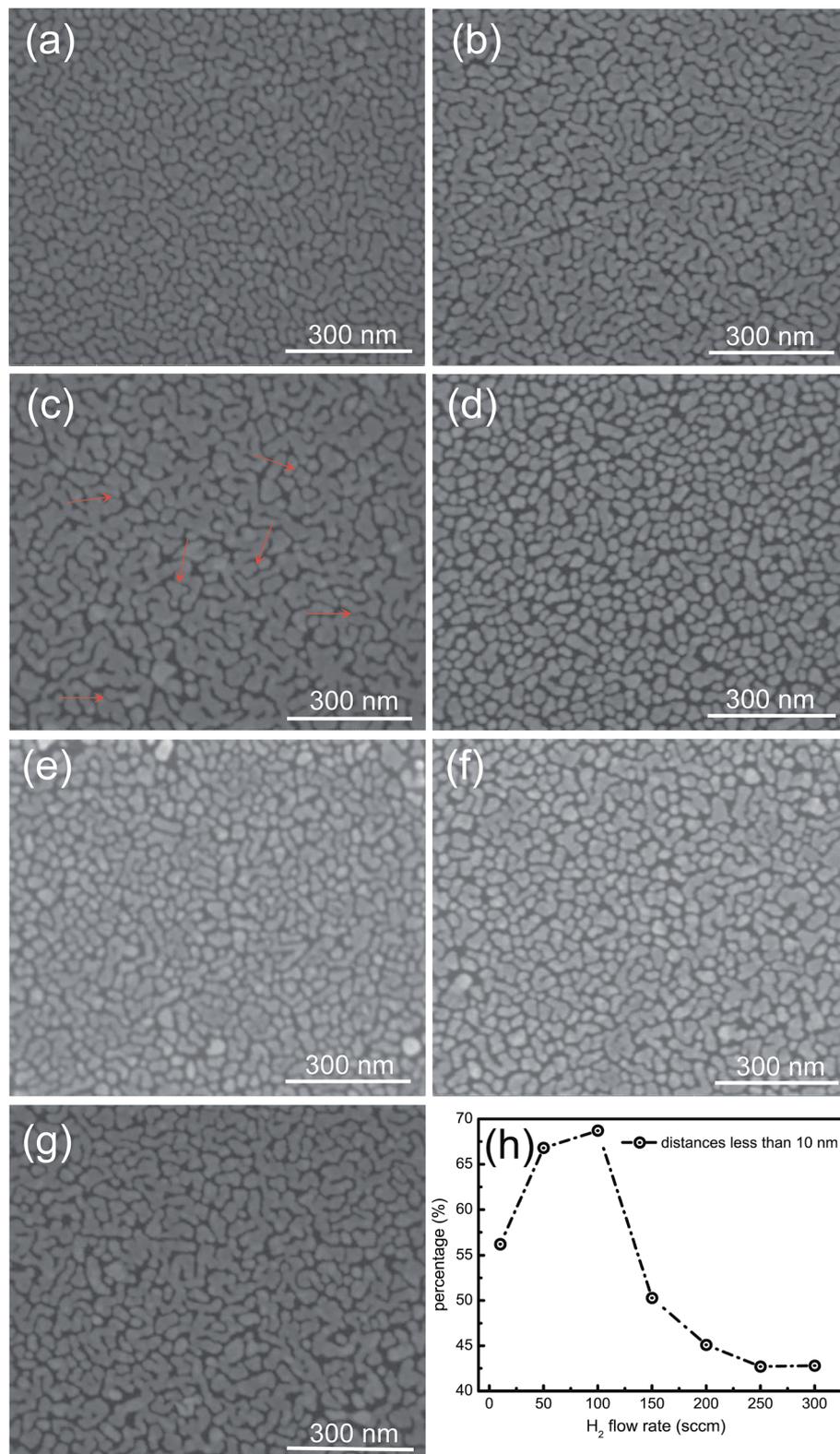


Fig. 3 (a–g) SEM images for Ag NPs on the samples of G₁₀, G₅₀, G₁₀₀, G₁₅₀, G₂₀₀, G₂₅₀ and G₃₀₀. (h) The percentage of distances between adjacent NPs less than 10 nm calculated from the corresponding SEM images.



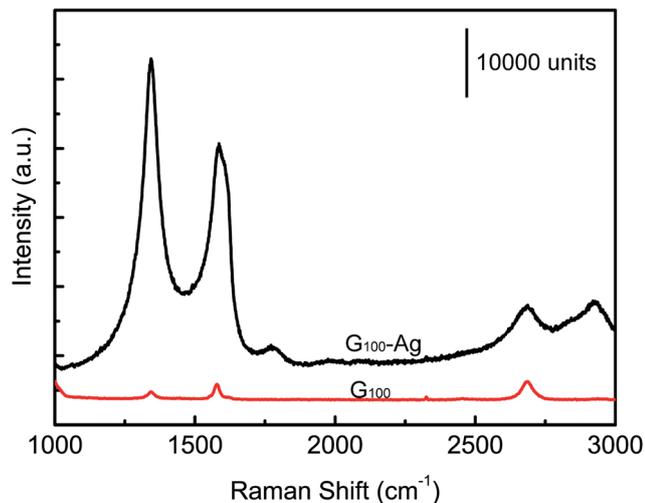


Fig. 4 Raman spectra for G_{100} and G_{100} -Ag.

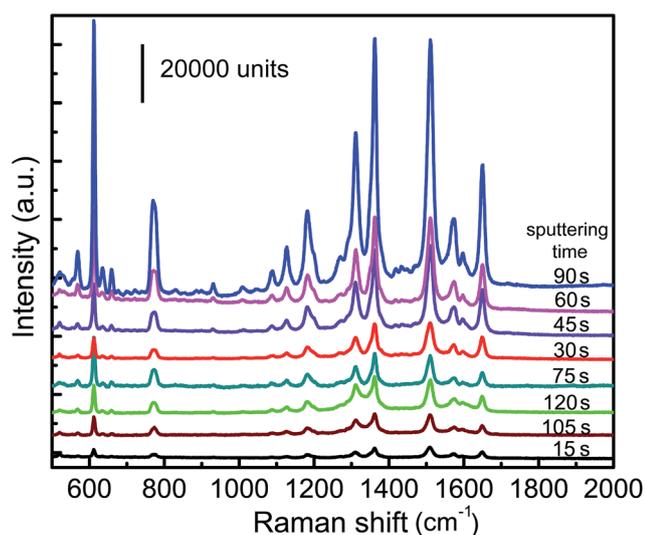


Fig. 5 Raman spectra of R6G molecules (10^{-5} M) on graphene (G_{10}) with Ag NPs prepared at different sputtering time.

3.4. SERS spectra of R6G on Ag/graphene composites

Fig. 5 shows that Raman spectra of R6G molecules (10^{-5} M) on the graphene substrate of the sample G_{10} with different characteristic Ag NPs, prepared by sputtering at different sputtering times ranging from 15 to 120 s. It can be observed that Raman intensity shows an increase when the sputtering time is increased from 15 to 90 s. However, the Raman intensity sharply decreases on the prolonging sputtering time. It is anticipated that the sizes of Ag NPs are small and the distances of Ag NPs are too large at shorter sputtering time, whereas the Ag NPs would be converted to continuous films when the sputtering time is very long. It is obvious that the Raman intensity shows a decrease when the sputtering time is either too short or too long. The Ag NPs prepared by sputtering for 90 s on uniform graphene show the strongest SERS signal.

Ag NPs were homogeneously sputtered on graphene sheets for an optimal depositing time of 90 s. Fig. 6a shows the SERS spectra of R6G for different Ag/graphene substrates including G_{10} -Ag, G_{50} -Ag, G_{100} -Ag, G_{150} -Ag, G_{250} -Ag, and G_{300} -Ag. The positions of the R6G characteristic peaks 1130 cm^{-1} , 1190 cm^{-1} , 1360 cm^{-1} , 1509 cm^{-1} , 1575 cm^{-1} , and 1650 cm^{-1} are generally in agreement with the previously reported measurement results.^{24,44} Amongst these samples, the sample G_{100} -Ag shows the strongest Raman intensity and the Raman intensity of sample G_{250} -Ag is the weakest compared with that of the other samples. The Raman intensity of G_{100} -Ag is almost 0.5×10^3 times stronger than that of the sample G_{250} -Ag. In general, SERS results from a combination of the EM and the CM. The EM plays a main role for SERS and it is originated from the morphology of the Ag NPs. The sample G_{100} contains much more C-O bonds, which contribute to controlling the distribution of the Ag NPs covered on it. The percentage for distances less than 10 nm for the sample G_{100} -Ag reaches a maximum value, and it would develop a maximum number of hot spots for SERS. The SERS EF change with the flow rate of hydrogen is shown in Fig. 6b. SERS EF is used to estimate the Raman enhancement effect amongst each sample. The SERS EF is calculated by the following formula:⁴⁵

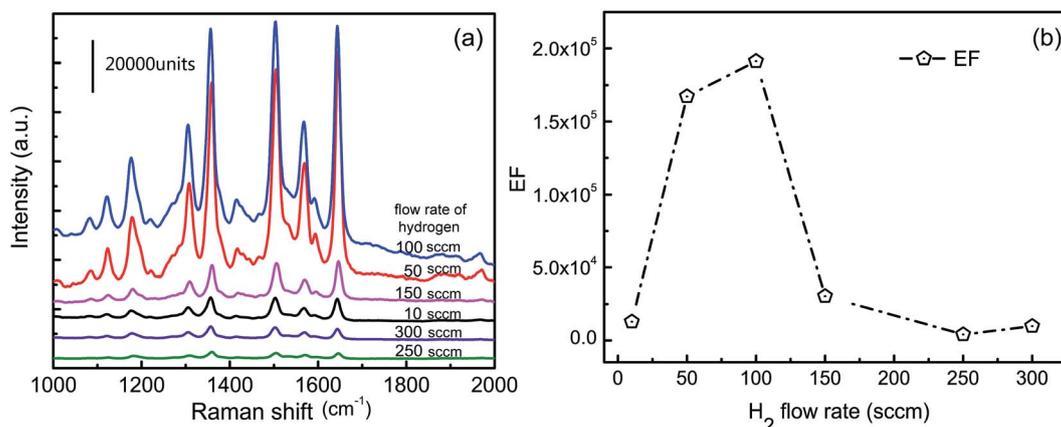


Fig. 6 (a) SERS spectra of 10^{-7} M R6G for various samples: G_{10} -Ag (90 s), G_{50} -Ag (90 s), G_{100} -Ag (90 s), G_{150} -Ag (90 s), G_{250} -Ag (90 s), and G_{300} -Ag (90 s). (b) The SERS enhancement factor (EF).



$$EF = \frac{I_{\text{SERS}}}{I_{\text{bulk}}} \times \frac{N_{\text{bulk}}}{N_{\text{SERS}}}$$

where I_{SERS} is the intensity of the probe molecules dripped to the SERS substrate and I_{bulk} is the intensity of the probe molecules dripped to the standard substrate. N_{SERS} and N_{bulk} are the number of probe molecules on the SERS substrate and standard substrate, respectively. The substrate with transferred graphene (G_{100}) but without Ag NPs was used as a standard substrate. It was observed that the EF was largest for the sample G_{100} -Ag and smallest for the sample G_{250} -Ag. The variation tendency of the percentage for C–O and the percentage for distances less than 10 nm between adjacent Ag NPs is similar to the SERS EF. This reveals that the percentage of C–O in graphene would directly affect the distribution and morphology of the deposited Ag NPS on graphene and consequently the SERS intensity.

4. Conclusion

Graphene with different amounts of defects and layers was obtained by controlling the flow rate of hydrogen during the reacting process. The Ag NPs covered on the prepared graphene formed irregular island shapes, affected by the defects, which mainly consisted of C–O bonds in graphene. It was considered that the C–O bonds in graphene have the ability to provide active sites to absorb Ag atoms or clusters to create growth cores for Ag NPS, which would be developed to form hot spots for SERS. The SERS EF, the percentage of C–O bonds, and the percentages of distances of less than 10 nm between adjacent Ag NPs have the similar variation trend. The EF of G_{100} -Ag shows the maximum reaching 10^5 , which is almost 0.5×10^3 times stronger than that of the sample G_{250} -Ag having the weakest effect of SERS.

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